Case No.: 58434US002

OIPE 32692 Custamer Number

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

irst Named Inventor:

MUYRES, DAWN V.

Application No.:

10/642919

Group Art Unit:

3712

Filed:

August 13, 2003

Examiner:

Unknown

Title:

METHOD FOR SEALING THIN FILM TRANSISTORS

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 **CERTIFICATE OF MAILING**

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on:

MAR 1 8 2004

Signed by: Hylis H. Froelke

Dear Sir:

Pursuant to 37 CFR §§ 1.56, 1.97, and 1.98, enclosed is a completed Form PTO-1449, citing references submitted for consideration by the Examiner. Copies of any cited foreign patents, non-patent literature, and unpublished US application documents are enclosed. Pursuant to the waiver in the Pre-OG Notice, dated July 11, 2003, copies of US patents and published US patent applications are no longer required and are not enclosed. It is respectfully requested that the Examiner initial and return the enclosed Form PTO-1449 to indicate that each reference has been considered.

If a first Office Action on the merits has been mailed prior to the mailing date of this document, please charge the fee for consideration of an Information Disclosure Statement set forth in 37 CFR § 1.17(p), and if necessary, please charge any additional fees, or credit any overpayment to Deposit Account No. 13-3723.

Respectfully submitted,

March 18, 2004

Date

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Office of Intellectual Property Counsel 3M Innovative Properties Company Facsimile No.: 651-736-3833

Substitute for form 1449A/PTO (modified)

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

Application Number 10/642919

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First Named Inventor Muyres, Dawn V.

Art Unit 3712

Examiner Name Unknown

Attorney Case Number 58434US002

(Use as many sheets as necessary)

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U.S. Patent Documents					
Example 1	THUBE	Document Number Doc. Number-(Kind Code if Known)	Publication Date or Issue Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
	A1	US- 2002/0063677 A1	05/30/2002	Drzaic	
	A2	US- 2002/0155729 A1	10/24/2002	Baldwin et al.	
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	A5	US- 2003/0105365 A1	06/05/2003	Smith et al.	
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Foreign Patent Documents							
Exam. Init.*	Cite No.	Foreign Patent Document		Publication Date	Name of Patentee or	Pages, Columns, Lines,	Translation
		Ctry. Code	Number-KindCode (If known)	MM-DD-YYYY	Applicant of Cited Document	Where Relevant Passages or Relevant Figures Appear	(Check if yes)
	B1	wo	02/05361 A1	01/17/2002			

OTHER PRIOR ART NON PATENT LITERATURE DOCUMENTS			
Exam. Init.*	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published	
	C1	M. G. KANE et al., "Analog and Digital Circuits Using Organic Thin-Film Transistors on Polyester Substrates", IEEE Electron Device Letters (November 2000), pp. 534-536, Vol. 21, No. 11	
	C2	I. KYMISSIS et al., "Patterning Pentacene Organic Thin Film Transistors", J. Vac. Sci. Techno. B, (May/June 2002), pp. 956-959, Vol. 20(3), American Vacuum Society	

*Examin	er	:
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Date Considered:

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

as many sheets as necessary)

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B TRI	DEMAR	OTHER PRIOR ART NON PATENT LITERATURE DOCUMENTS
Exam. Init.*	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published
	С3	H. KLAUK, "Contact Resistance in Organic Thin Film Transistors", Solid-State Electronics, (2003), pp. 297-301, Vol. 47
	C4	S. M. SZE, Physics of Semiconductor Devices, 2 nd Edition, (1981), p. 442, John Wiley & Sons, New York
	C5	L. C. SANDER et al., "Polycyclic Aromatic Hydrocarbon Structure Index", NIST Special Publication 922, (December 1997), U. S. Gov't Printing Office, Washington, DC
	C6	U.S.S.N. 10/434377, Filed May 8, 2003, "Organic Polymers, Electronic Devices, and Methods"
	C7	U.S.S.N. 10/620027, Filed July 15, 2003, "Bis(2-Acenyl)Acetylene Semiconductors"

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